

**EXPEDITED PROCEDURE**  
**Examining Group Number 2818**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Hong-Jyh Li et al.	Examiner:	Quoc Dinh Hoang
Serial No.:	10/799,910	Group Art Unit:	2818
Filed:	March 12, 2004	Docket No.:	2004P50029US/I331.135.101
Title:	ION IMPLANTATION OF HIGH-K MATERIALS IN SEMICONDUCTOR DEVICES		

---

**RESPONSE UNDER 37 C.F.R. 1.116**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Response is in reply to the Final Office Action mailed March 27, 2007.